Claims

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- 1. Machine for cutting an opening, such as a window in a planar substrate (1), said machine having at least a cutting tool (12) characterised in that it comprises a transfer system (7,8) holding said substrate (1) and driving said substrate along a determined direction, and in that the cutting tool (12) comprises a laser beam (13) that can be moved in two perpendicular directions and evacuation means (11,15) to evacuate a cut part of said substrate (1).
 - 2. Machine as claimed in claim 1, wherein it further comprises an aspiration box (9) to maintain the substrate (1) during the cutting operation.
 - 3. Machine as claimed in claim 2, wherein said aspiration box (9) comprises a bottom wall (17) with aspiration openings (10) and a cutting opening (14).
- 4. Machine as claimed in one of the preceding claims, wherein said transfer system is a chain gripper system (17).
- 5. Machine as claimed in one of the preceding claims, 25 wherein said laser (12) is displaced linearly or rotationally.
 - 6. Machine as claimed in one of claims 1 to 4, wherein said laser beam (13) is displaced linearly or rotationally.
 - 7. Machine as claimed in one of the preceding claims, wherein it further comprises a laminate application unit

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for applying a strip of laminate over the cut opening of the substrate.

- 8. Process for cutting an opening, such as a window, in a planar substrate, said process being characterised by the following steps:
 - -) holding said substrate with a gripper,
 - -) moving said substrate along a given direction,
 - -) applying said substrate against a surface,
- illuminating said substrate with a laser beam to cut an opening in said substrate,
 - -) evacuating the cut part of said substrate.
- Process according to claim 8, wherein said application
 step of substrate against a surface is made by using air under depression.
- 10. Process according to claim 8 or 9, wherein said evacuation step is made by aspiration means with air under depression.
 - 11. Process according to one of claims 8 to 10, wherein said laser beam is displaced along two orthogonal axes.
- 25 12. Process according to one of claims 8 to 11, wherein said laser beam is rotated around two orthogonal axes.

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- 13. Process according to one of claims 8 to 12, wherein a mirror displaces said laser beam.
- 14. Process according to one of claims 8 to 13, wherein it further comprises the step of applying laminate over the cut opening of the substrate.